

Notice of References Cited	Application/Control No. 10/720,340		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Ricky L Mack		Art Unit 2873	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,811,263 B2	11-2004	Kim et al.	353/31
	B	US-6,824,270 B2	11-2004	Kim et al.	353/31
	C	US-2002/0027642 A	03-2002	Nishida et al.	353/53
	D	US-2002/0048000 A1	04-2002	Nishida et al.	353/98
	E	US-2003/0072084 A1	04-2003	Ouchi, Satoshi	359/634
	F	US-2004/0057018 A1	03-2004	Cho et al.	353/031
	G	US-2004/0233342 A1	11-2004	Kim et al.	349/006
	H	US-2004/0246445 A1	12-2004	Cho et al.	353/031
	I	US-2004/0246590 A1	12-2004	Ouchi, Satoshi	359/634
	J	US-2004/0257387 A1	12-2004	Cho et al.	345/690
	K	US-2004/0263793 A1	12-2004	Kim et al.	353/033
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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